

ATTORNEY DOCKET NO.  
TI-37647 (032350.B584)

1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Roger M. Ikeda, et al.  
Filing Date: December 30, 2003  
Title: Notched Adjustable Aperture

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

INFORMATION DISCLOSURE STATEMENT

Applicants respectfully request, pursuant to 37 C.F.R. §§1.56, 1.97, and 1.98, that the documents listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application. Furthermore, pursuant to 37 C.F.R. §§1.97(g) and (h), Applicants make no representation that these documents qualify as prior art or that these documents are material to patentability of the present application or that a search has been made.

ATTORNEY DOCKET NO.  
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2

PATENT APPLICATION

Since the present Application is filing after June 30, 2003, a copy of any U.S. Patent and any U.S. Patent Application Publication cited on the attached PTO Form 1449 is not being submitted with this Information Disclosure Statement pursuant to the July 11, 2003 waiver of 37 C.F.R. S 1.98(a)(2)(i) by the U.S. Patent and Trademark Office.

Respectfully submitted,  
BAKER BOTTS L.L.P.  
Attorneys for Applicants



Kevin J. Meek  
Reg. No. 33,738

**Correspondence Address**

2001 Ross Avenue  
Suite 600  
Dallas, Texas 75201-2980  
(214) 953-6680

Date: December 30, 2003

Customer Number:

**23494**

Patent Trademark Office

<b>PTO-1449</b>  <b>Information Disclosure Citation in an Application</b>			<b>Application No.</b>  <b>Docket Number</b> <b>TI-37647</b> <b>(032350.B584)</b>		<b>Applicant(s)</b> <b>Roger M. Ikeda, et al.</b>  <b>Group Art Unit</b>  <b>Filing Date</b> <b>December 30, 2003</b>		
<b>U.S. PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
	<b>A</b>	5,442,414	08/15/1995	Janssen et al.	353	98	05/10/1994
	<b>B</b>	2002/0126264 A1	09/01/2002	Dewald et al.	353	97	03/05/2002
	<b>C</b>						
	<b>D</b>						
	<b>E</b>						
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	<b>G</b>						
	<b>H</b>						
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	<b>J</b>						
	<b>K</b>						
	<b>L</b>						
	<b>M</b>						
<b>FOREIGN PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b> <b>YES</b> <b>NO</b>
	<b>N</b>						
	<b>O</b>						
	<b>P</b>						
<b>NON-PATENT DOCUMENTS</b>							
		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>					<b>DATE</b>
	<b>Q</b>	L.J. Hornbeck, "Digital Light Processing™: A New MEMS-Based Display Technology," Texas Instruments, white paper, 22 pages					
	<b>R</b>	G. Hewlett and W. Werner, "Analysis of Electronic Cinema Projection with the Texas Instruments Digital Micromirror Device™ Display System," Texas Instruments, white paper, 10 pages					
	<b>S</b>	S.M. Penn, et al., "Adaptive Illumination Modulator," S/N 10/326,237, currently pending					12/20/2003
	<b>T</b>						
	<b>U</b>						
	<b>V</b>						
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>			
<b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							